

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Michel Puech

Appl. No.: 10/516,457

Confirm. No.: 2874

Filed: December 3, 2004

Title: HEATING JACKET FOR PLASMA ETCHING  
REACTOR, AND ETCHING METHOD USING SAME

PATENT APPLICATION

Art Unit: 1716

Examiner: Jeffrie Robert Lund

Customer No. 23910

REPLY and AMENDMENT TO OFFICE ACTION

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This REPLY is in response to the Office action mailed October 12, 2010 in light of the Interview of December 21, 2010 for the above-referenced application as follows:

**Amendments to the Claims** begins on page 2 of this paper.

**Summary of the Substance of the Interview** begins on page 7 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.

**Declaration Under 37 CFR 1.132** begins on page 13 of this paper.